



Attorney's Docket No.: 005794 ALRT/ETCH/CONE/
Confirmation No.: 3777

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

Mark N. Kawaguchi, et al.)

Application No: 09/978,121)

Filed: October 15, 2001)

For: A METHOD OF PHOTORESIST REMOVAL)
IN THE PRESENCE OF A DIELECTRIC)
LAYER HAVING A LOW K-VALUE)

) Examiner: Allan W. Olsen

) Art Unit: 1763

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TC 1700

Mail Stop: Non-Fee Amendment
Commissioner For Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated June 30, 2003, Applicant respectfully requests that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to MS: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on:

September 30, 2003

Date of Deposit

Dianne Neathery

Name of Person Mailing Correspondence

Dianne Neathery
Signature

September 30, 2003

Date

Amendment/Response
BSTZ Ref. 04887.P578

1/11

Examiner: Allan W. Olsen
Docket: 005794 ALRT/ETCH/CONE/